

Journal of Integrated Circuits and Systems

Volume 12 • Number 1 • April 2017 • ISSN 1807-1953

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R. A. Souza, L. G. M. Ventura, A. R. S. Martins, D. W. de Lima Monteiro, L. P. Salles



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JICS - Journal of Integrated Circuits and Systems

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Systems

Volume 12 • Number 1 • April 2017 • ISSN 1807-1953

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FOREWORD

We are pleased to publish the 2017 issues of JICS, which represents the third year in the path to increase visibility and attraction of high quality papers, by publishing three issues instead of two.

In this issue one can find some of the papers that have been selected from those presented at SBMicro2016 (31th Symposium on Microelectronics Technology and Devices) and SBCCI2016 (29th Symposium on Integrated Circuits and Systems Design), which have been held in Belo Horizonte, Brazil, in 2016. Among the contributions presented at both Symposia, only a few best rated were selected by the JICS Editorial Board and have been invited to submit an extended version to the Journal. These extended papers have passed through the usual reviewing process before acceptance.

In addition to the best papers presented at these conference, spontaneous submissions passed through the usual reviewing process and have been accepted as regular papers.

We would like to thank the authors for their effort in preparing these high quality papers, as well as the reviewers for their valuable contribution on paper evaluation and selection, which guarantees the scientific level of this issue. We sincerely hope that JICS readers will enjoy these contributions.

Marcelo Antonio Pavanello
JICS Editor-in-chief